

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of )  
MARTIN RICHARDSON )  
Serial No: TBA )  
Filed: Concurrently Herewith )  
For: EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA PRODUCED  
FROM LIQUID METAL SOLUTIONS, AND NANO-SIZE PARTICLES IN SOLUTIONS )

INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner of Patents  
and Trademarks  
Washington DC 20231

Sir:

Pursuant to the requirements of 37 CFR 1.97 and 1.98, Applicant hereby requests that the references listed in the attached form PTO-1449 be considered and made of record in the above-identified application.

Favorable consideration of the application at an early date is respectfully solicited.

Respectfully submitted,

By:   
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Date: 10/19/07